Graduate School of Information, Production and Systems, Waseda University

Time Table 2025-2026
1period 8:50~10:30, 2 period 10:40~12:20, 3 period 13:10~14:50, 4 period 15:05~16:45, 5 period 17:00~18:40, 6 period 18:55~20:35

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		Monday			Tuesday				Wednesday			Thursday				Friday	Saturday						
Period	System	Course Title	Inst	uctor	Room	Course Title	inspage	Instructor	Room	Course Title	Instructor	Roon	Course Title	impope	Instructor	ROOM			Instructor Room	Course Title	inguspe	Inst	tructor Room
1	FS									Robotics	E-J MATSUMARI	J \$104	Surface Science	E٠J	MIYAK	E \$151	Fundamentals of Organic Electronics I	E	MEHES, Gabor \$104		'		
	4.0					Bioengineering	E-J	MATSUMARU	\$104				Semiconductor Device Technology and Engineering	E+J	TANZAW	A S104					H		
	AS					Biomicromachine	E٠J	MIYAKI	\$101												Ш,		
	SS	Robotics and mechatronics	E-J MATS	UMARU		Community Computing Smart Industry	E-J	YOSHII		Current Bioelectronics	E-J MIYAK	E	Example-based machine translation/NLP	E	LEPAGE, Yve	<u> </u>	Functional Thin Films	E-J	UEDA		'		
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										Information Organization	E IWAIHARA		Fiber optic measurement technology	E٠J	TSUBOKAW.	S153	Optical Circuit Simulation Technology	Е	KAKITSUKA N159		T		
	AS									Micro and Nano Fluidic Device Engineering	E-J MAWATAR	\$101	Physics and Technology of Semiconductor MOS Devices	E٠J	SHIMUR	\$ \$101					ļ	,	
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										Light Emitting Systems	E-J KAKITSUKA												
	H					Community Computing A	E. I	YOSHII	-	Integrated System Optimization Mechanical System Design A	E-J YAMASAK E-J TANAKA	3103	Robotics and mechatronics D	Fr I	MATSUMAR	1	Intelligent Acquistic Systems D	F. I	MAKINO \$103	Bioelectronics A	E+J	Η,	MIYAKE
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	FS					Fundamental Biosystems	F	KAMEOKA	\$101	Optical fiber engineering Design of Machine Elements	E-J ISUBOKAWA		Special Exercise of Community Computing II	F+1	IEI	S151	Fundamentals of Organic Electronics II Pattern Recognition	E-1	KAMATA S101		+-	┢	
	AS		·			fackaging and Assembly Technologies for Integrated Systems	E٠J	YAMASAK	\$104	Video Signal Processing	E-J IKENAGA	S101	Thin Film Processing	E٠J	UED	S101	Analog LSI Design	E٠J	IKEHASHI N105				
3													Optical Semiconductor Devices	E٠J	TAKAHAT	× S155					Ш'		
	LW					Laboratory Works on Production Systems	J	IWAIHARA	N106 etc		E∙J FURUZU≱								TSUBOKAWA		-		KAWA .
						Data Engineering Image Information Systems	E F-1	IKENAGA	\$102	Computational Neuroscience High-Level Verification Technologies	E-J FURUZUE	1 5155					Advanced fiber optic technologies	E-J	ISUBOKAWA	Design Engineering and System	E-J	ARA	KAWA
	SS		·						1	Wireless Communication Circuits Technologies	E-J YOSHIMASI	S102						••••					
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						Image Media D Community Computing D	E-J	KAMATA	ļ	Example-based machine translation/NLP A	E-J TAKAHASH		Database System A Example-based machine translation/NLP D	E-J	IWAIHAR.		Micro and Nano Fluidic Device A	E٠J	MAWATARI	lmage Media A Bioelectronics D	E-J		AMATA MIYAKE
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						Bioinformatics	E٠J	FURUZUK	\$101	Medical Device Engineering	E-J TAKAHASH	II S104	Smart factory I (Fall Quarter)	Ε	YOSHI		Internet of Things and Big Data	Ε	WU \$101				
	AS					High-speed, High-frequency LSI Design	E	YOSHIMASI	\$151				Design of Heurific Search and its Application	E٠J	ARAKAW	× \$103	Special Exercise of Organic Electronics I Finite Element Analysis	Е	MEHES, Gabor \$151 YAMASAKI N159		'		
	IW					Laboratory Works on Production Systems	-		N106 etc			╁				-	Hinite Element Analysis	ErJ	YAMASAKI N159		+	⊢	
4	Ħ					Intelligent Acoustic Systems	E٠J	MAKINO	\$103	Mechanical System Design	E-J TANAK	4	Information and Production Process	E٠J	TATENO	\$207	Micro Electro-Mechanical Systems	E-J	IKEHASHI		T	Г	
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						Network Intelligence and Security D Image Information Systems D	E٠J	IKENAGA	\$102	Mobile Robotics Platform A	E-J FURUZUR E-J HASHIMOTO	3135	Database System D Bio Information Sensing D	E٠J	IWAIHAR. KAMEOK		Micro and Nano Fluidic Device D	E-J	MAWATARI		 '	 	
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	4.0					Information Management (Fall Quarter)	J	TATENO	\$153	System LSI Design	E IKENAGA	A N105	Information Design	E٠J	IEI	S104	Information Security Engineering	E-J	KAMATA \$101		H	\vdash	
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